

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

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| Applicant: | Davis, et al. | Case: | APPM/8381/ETCH/SILICON |
| Serial No.: | 10/805,136 | Filed: | March 19, 2004 |
| Examiner: | Dahimene, Mahmoud | Group Art Unit: | 1765 |
| Conf. No.: | 8916 | | |
| Title: | METHOD FOR CONTROLLING A PROCESS FOR FABRICATING INTEGRATED DEVICES | | |

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED FEBRUARY 7, 2006

S I R:

In response to the Office Action dated February 7, 2006, having a shortened statutory period for response expired on May 7, 2006, please enter this Response and reconsider the claims pending in the application for reasons discussed below. The Applicants believe that no fee is due in connection with this response. However, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including extension of time fees or excess claims fees, as required to make this response timely and acceptable to the Office.